

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/598,762	ONISHI ET AL.	
Examiner	Art Unit	
Daniel St.Cyr	2876	

SEARCHED							
Class	Subclass	Date	Examiner				
235	486 489 490 487	9/16/2009	DS				

INTERFERENCE SEARCHED				
bclass	Date	Examiner		

SE/ (INCLUDING	ARCH NOT	ES STRATEGY)
·		DATE	EXMR
EAST		9/16/2009	DS